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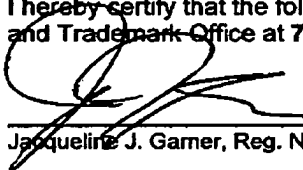
JAN 03 2005

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: DeLoach et al. Art Unit: 2822  
Serial No.: 10/703,387 Examiner: Thomas, T.  
Filing Date: 11/06/2003 Docket No.: TI-35862  
Customer No.: 23494 Conf. No.: 9996  
Title: FORMING A TRENCH TO DEFINE ONE OR MORE ISOLATION  
REGIONS IN A SEMICONDUCTOR STRUCTURE

## CERTIFICATION OF FACSIMILE TRANSMISSION

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Jacqueline J. Garner, Reg. No. 36,144 January 3, 2005  
Date

## FACSIMILE COVER SHEET

<input checked="" type="checkbox"/> <b>FACSIMILE COVER SHEET</b>	<input checked="" type="checkbox"/> <b>AMENDMENT (7 Pages)</b>
<input type="checkbox"/> NEW APPLICATION	<input checked="" type="checkbox"/> <b>EOT 3mth (3 Pages)</b>
<input type="checkbox"/> DECLARATION (# Pages)	<input type="checkbox"/> NOTICE OF APPEAL (# Pages)
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<input type="checkbox"/> CONTINUATION APP'N (# Pages)	
<input type="checkbox"/> DIVISIONAL APP'N	
<b>NAME OF INVENTOR(S):</b> De Loach	
<b>TITLE OF INVENTION:</b> Forming a Trench . . .	
<b>TI FILE NO.:</b> TI-35862	<b>DEPOSIT ACCT. NO.:</b> 20-0668
<b>FAXED:</b> 1/3/2005 <b>DUE:</b> JJG <b>ATTY/SEC'Y:</b> JJG	
<b>RECEIPT DATE &amp; SERIAL NO.:</b> <b>Serial No.: 10/703,387</b> <b>Filing Date: 11/06/2003</b> <b>Conf. No.: 9996</b>	

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## AMENDMENT UNDER 37 CFR 1.111

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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Jacqueline J. Garner  
Reg. No. 36,144

Dear Sir:

The following amendments and remarks are offered in response to the Examiner's Office Action dated 7/1/2004. They are respectfully submitted as a full and complete response to that Action.

Please amend the above-referenced application as follows:

There are no **Amendments to the Specification.**

**Amendments to the Claims** are reflected in the listing of claims that begin on page 2 of this paper.

There are no **Amendments to the Drawings.**

The **Remarks** begin on page 7.